Application Data Sheet

Application Information

Application number::

Filing Date::

Application Type::

Subject Matter::

Title ::

Attorney Docket Number::

Total Drawing Sheets::

Small Entity?::

Regular

Utility

METHOD OF

MANUFACTURING A

SEMICONDUCTOR DEVICE

0756-7175

16

No

Applicant Information

Applicant Authority Type::

Primary Citizenship Country::

Given Name::

Middle Name::

Family Name::

Name Suffix::

City of Residence::

State or Province of Residence::

Country of Residence:: Street of mailing address::

City of mailing address::

Inventor

Japan

Tamae

TAKANO

Atsugi

Kanagawa

Japan

c/o Semiconductor Energy

Laboratory Co., Ltd., 398,

Hase

Atsugi-shi

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Initial 07/08/03

State or Province of mailing address::

Kanagawa-ken

Country of mailing address::

Japan

Postal or Zip Code of mailing address::

243-0036

Correspondence Information

Correspondence Customer Number ::

31780

E-Mail address::

erobinson@riplo.com

Representative Information

Representative Customer Number::

31780

Domestic Priority Information

Application ::	Continuity Type::	Parent Application::	Parent Filing Date::

Foreign Priority Information

Country::	Application number::	Filing Date::	Priority Claimed::
Japan	2002-200555	07/09/2002	Yes

Assignee Information

Assignee name:: Semiconductor Energy

Laboratory Co., Ltd.

Street of mailing address:: 398 Hase

City of mailing address:: Atsugi-shi

State or Province of mailing address:: Kangawa-ken

Country of mailing address:: Japan

Postal or Zip Code of mailing address:: 243-0036